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**PATENT**

Case Docket No. ASMMC.036AUS

Date: December 14, 2001

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s) : SOPHIE et al.  
App. No. : 09/975,466  
Filed : October 9, 2001  
For : IN SITU REDUCTION OF  
COPPER OXIDE PRIOR TO  
SILICON CARBIDE  
DEPOSITION

I hereby certify that this correspondence and all  
marked attachments are being deposited with the  
United States Postal Service as first class mail in an  
envelope addressed to: Commissioner for Patents,  
Washington, D.C. 20231, on

December 14, 2001

(Date)

*Adeel S. Akhtar*

Adeel S. Akhtar, Reg. No. 41,394

Group Art Unit : 2812

**TRANSMITTAL LETTER**

**COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231**

ATTENTION: BOX MISSING PARTS

Dear Sir:

In response to the Notice to File Missing Parts of Application Under 37 CFR 1.53(f),  
which was mailed by the Office on November 14, 2001, enclosed are:

- (X) An executed Declaration by Inventors.
- (X) A Power of Attorney Form and Copy of Assignment.
- (X) A Notice to File Missing Parts.
- (X) Return prepaid postcard.
- (X) Fees as calculated below: